

Electronic Acknowledgement Receipt

EFS ID:	2866491
Application Number:	10516455
International Application Number:	
Confirmation Number:	2876
Title of Invention:	Method and device for substrate etching with very high power inductively coupled plasma
First Named Inventor/Applicant Name:	Michel Puech
Customer Number:	23373
Filer:	Michael R. Dzwonczyk/Lynette Mansfield
Filer Authorized By:	Michael R. Dzwonczyk
Attorney Docket Number:	Q84452
Receipt Date:	15-FEB-2008
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Application Type:	U.S. National Stage under 35 USC 371

Payment information:

Submitted with Payment	yes
Payment Type	Deposit Account
Payment was successfully received in RAM	\$ 1050
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)/Message Digest	Multi Part /.zip	Pages (if appl.)
1		Q84452Amendment.pdf	225074 361089c9a010f04e23e00824d27aad1a5b59354	yes	7
Multipart Description/PDF files in .zip description					
	Document Description		Start		End
	Amendment - After Non-Final Rejection		1		1
	Claims		2		3
	Applicant Arguments/Remarks Made in an Amendment		4		6
	Extension of Time		7		7

Warnings:

Information:

2	Fee Worksheet (PTO-06)	fee-info.pdf	8212 c36ee4310f0675e146e4d29e1d927ea093249f	no	2
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Warnings:

Information:

Total Files Size (in bytes): 233286

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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.